

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Takehisa Yahiro

Application No. 10/000,458

Filed: November 30, 2001

Confirmation No. 2299

For: METHODS AND DEVICES FOR
EVALUATING BEAM BLUR IN A
CHARGED-PARTICLE-BEAM
MICROLITHOGRAPHY APPARATUS

Examiner: Mary A. El Shammaa

Art Unit: 2881

Attorney Reference No. 4641-61273

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CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney
for Applicant(s)

Donald L. Stephens

Date Mailed October 9, 2003

INFORMATION DISCLOSURE STATEMENT PURSUANT TO
37 C.F.R. § 1.97(c)

Listed on the accompanying form PTO-1449 and enclosed herewith are several English-language and/or non-English-language documents. Applicant respectfully requests that these documents be listed as references cited on the issued patent. This Information Disclosure Statement ("IDS") is being mailed before Applicant received a final action, a notice of allowance, or an action that otherwise closes prosecution in the referenced application.

Submitted herewith is a check for \$180.00 as required by 37 C.F.R. § 1.17(p) for filing this IDS in compliance with 1.97(c).

Please charge any additional fees which may be required in connection with filing this IDS, or credit any overpayment, to Deposit Account No. 02-4550. A duplicate copy of this sheet is enclosed.

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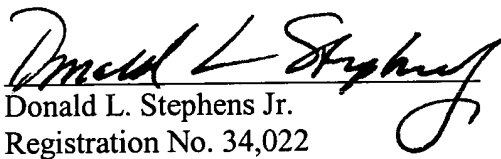
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The filing of this IDS shall not be construed to be an admission that the information cited in the statement is, or is considered to be, prior art or otherwise material to patentability as defined in 37 C.F.R. §1.56.

Respectfully submitted,

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Attorney Docket Number	4641-61273
				Application Number	10/000,458
				Filing Date	November 30, 2001
				First Named Inventor	Yahiro
				Art Unit	2881
				Examiner Name	Mary A. El Shammas
U.S. PATENT DOCUMENTS					
Examiner's Initials*	Cite No. (optional)	Number	Date	Name	
		6,059,981	9-May-2000	Nakasuji	
		5,396,077	7-Mar-1995	Sohda et al.	
FOREIGN PATENT DOCUMENTS					
Examiner's Initials*	Cite No. (optional)	Number	Date	Country	
		P2001-203149A	27-Jul-2001	Japan	
Examiner's Initials*	Cite No. (optional)	OTHER DOCUMENTS			
		"New imaging and deflection concept for probe-forming microfabrication systems", by H.C. Pfeiffer, J. Vac. Sci, Technol., Vol 12, No. 8, Nov./Dec. 1975, pages 1170-1173			

EXAMINER SIGNATURE:	DATE CONSIDERED:
* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.	